JUN 1 5 2004 JUN

INFORMATION DISCLOSURE CITATION

AND MASKET NO.	9118.0002	Appin. No.	10/814,243
Applicant	David Peter VAN HEERDEN et al.		
Filing Date	April 1, 2004	Group:	Unknown

·	U.S. PATENT DOCUMENTS					
Examiner Initiat*	Document . Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
(A)	5,381,944	01/1995	Makowiecki et al.	ا		
0	5,538,795	07/1996	Barbee, Jr. et al.			
	5,547,715	08/1996	Barbee, Jr. et al.		_	
10	6,534,194 B2	03/2003	Weihs et al.	<u>ر</u>		
-30	6,736,492 B2	05/2004	Weihs et al.		_	
28	6736942					

Document Number Publication Date Name Class Sub Class Filing Date Filing Date Filing Date Sub Class Filing Date Filing Date	U.S. PATENT APPLICATIONS						
10/247,998 Weihs et al.				Name	Class		
10/761,439 Weihs et al 01/21/2004 10/761,440 Weihs et al 01/21/2004 10/761,442 Weihs et al 01/21/2004 10/761,443 Weihs et al 01/21/2004 10/761,444 Weihs et al 01/21/2004 10/761,685 Weihs et al 01/21/2004	A	2002/0182436 A1	12/2002	Weihs et al.		j	
10/761,440 Weihs et al	X	10/247,998	1	Weihs et al.	·	(01/21/2004
10/761,442 Weihs et al 01/21/2004 10/761,443 Weihs et al 01/21/2004 10/761,444 Weihs et al 01/21/2004 10/761,685 Weihs et al 01/21/2004		10/761,439		Weihs et al.		ـنــ	01/21/2004
10/761,443 Weihs et al. — 01/21/2004 10/761,444 Weihs et al. — 01/21/2004 10/761,685 Weihs et al. — 01/21/2004		10/761,440		Weihs et al.	_		01/21/2004
10/761,444 Weihs et al. — 01/21/2004 10/761,685 Weihs et al. — 01/21/2004		10/761,442		Weihs et al.			01/21/2004
10/761,685 Weihs et al		10/761,443		Weihs et al.			01/21/2004
To Tool Tool		10/761,444		Weihs et al.		_	01/21/2004
10/761,688 Weihs et al 01/21/2004	10	10/761,685		Weihs et al.		-	01/21/2004
	The state of the s	10/761,688		Weihs et al.		-	01/21/2004
			,				

	OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)
No.	R.J. Blobaum, et al., "Deposition and Characterization of a Self-Propagating CuOx/Al Thermite Reaction in a Multilayer Foil Geometry," Journal of Applied Physics, Vol. 94(5), pp. 2915-2922, September 1, 2003.
8	T.P. Weihs, "Self-Propagating Reactions in Multilayer Materials," published in the 1998 edition of the <i>Handbook of Thin Film Process Technology</i> edited by D.A. Glocker and S.I. Shah, 7 pages, (1998).